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Docket No.: 2328-053

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : EXPEDITED PROCEDURE
 Tuqiang NI et al. : Response under 37 CFR 1.116
 U.S. Patent Application No. 09/821,753 : Confirmation No. 5171
 Filed: March 30, 2001 : Group Art Unit: 1763
 For: PLASMA PROCESSING METHOD AND APPARATUS WITH CONTROL OF
 PLASMA EXCITATION POWER : Examiner: ALEJANDRO MULERO, LULZ L.

*Entered with RCE
 8/29/5
 MW 9/2/5*

AMENDMENT UNDER RULE 116

Commissioner for Patents
 PO Box 1450
 Alexandria, VA 22313-1450

December 20, 2004

Sir:

This paper is submitted in reply to the Office Action mailed October 19, 2004, which was made Final. Applicants respectfully request that the following amendments be entered to place this application in condition for allowance.

I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMILE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE ON THE DATE SHOWN BELOW

Alice Weaver
 TYPE OR PRINT NAME OF PERSON SIGNING CERTIFICATION
Alice Weaver 12-20-04
 SIGNATURE DATE
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